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Abstract

The dynamics of micro-piezoelectric resonators can be profoundly affected by immersion in fluids. Aluminum nitride-based piezoelectric microresonators are fabricated and tested under controlled pressures in several gases. The cases on microresonator vibrating in fluid can be broadly divided into: (i) those that deal with vibration in free space and (ii) close to a surface. For the first case, experimental and analytical results for the hydrodynamic loading characteristics of the resonators at different resonant modes have been investigated, as well as the influences of fluid viscosity and compressibility. For the second case, most prior efforts have been focused on squeeze-film damping with very narrow gaps, while in many practical applications, the resonators vibrate close to a surface with a moderate distance. Experiments by using a micro-bridge resonator with a big range of gaps are performed and compared with predictions from theoretical models.

Keywords: aluminum nitride, fluid-structure interaction, viscous damping, compressibility, wall effect

1. Introduction

Piezoelectric microresonators have been recently used in a large variety of applications [1–9], due to their tiny structures [10] and ultrahigh sensitivity [11], let alone their self-exciting and self-sensing capability, together with full integration, as compared to electrostatic [12], electromagnetic [13], or optically associated [14] structures. Regarding the piezoelectric materials, aluminum nitride (AlN) was selected in this work, to be compatible with complementary metal-oxide-semiconductor (CMOS) technology. Besides, by carefully controlling the fabrication parameters [15], AlN film with high piezoelectric coefficients and low intrinsic stress can be obtained.
Microresonators are normally operated in fluids (such as air or liquid) at atmosphere or under reduced pressure. The resonator parameters, such as resonance frequency \( f_r \), quality factor \( Q \) or phase shift, may change due to environmental influences. The \( Q \) factor is defined as the ratio of stored energy to the dissipated energy per cycle, equivalents to \( f_r/\Delta f \), where \( \Delta f \) is the peak width at half power. In general, a high \( Q \) factor is preferred for micro-resonator sensors, as high \( Q \) factor results in a sharper resonance peak and a better detectable resolution.

The energy loss \( Q^{-1} \) for a resonator consists of intrinsic energy loss \( Q_{\text{int}}^{-1} \) (e.g., radiation of elastic energy into attachment and structural friction) [16] and external losses \( Q_{\text{flu}}^{-1} \) (e.g., acoustic, viscous, and squeeze-film damping) into the surrounding fluid. \( Q_{\text{int}}^{-1} \) can be measured by operating the resonator in a high vacuum. When operating in a fluidic environment, \( Q_{\text{flu}}^{-1} \) would be the major energy loss source. The cases on microresonator vibrating in fluid can be broadly divided into (i) those that deal with vibration in free space and (ii) close to a surface. Experimental and analytical results for the hydrodynamic loading characteristics of the resonators in both cases are presented in this chapter.

2. Experimental techniques

In this section, we describe the experimental techniques, including the device fabrication, packaging, measurement setup, and electric readout. Piezoelectric AlN-based resonators were fabricated and tested.

2.1. AlN-based piezoelectric microresonator fabrication

The AlN thin films were deposited using reactive sputtering. Films with good c-axis orientation [15] have been successfully achieved, and the effective piezoelectric constants were measured as: \( d_{33} = 3 \text{ pm/V} \) and \( d_{31} = -1.0 \text{ pm/V} \) [17]. Low resistivity (less than 0.1 \( \Omega \text{ cm} \)) p-type (100) single crystal silicon (SCS) wafer was used as a resonating element, serving simultaneously as a bottom electrode. The fabrication process is shown as in Figure 1. The SCS wafer was oxidized in high temperature furnace to form 120 nm thick \( \text{SiO}_2 \) layers on both sides, and then a 500 nm thick PECVD Si\(_x\)N\(_y\) layer was deposited on the bottom side of the wafer (Figure 1a). In a next step, a 1 \( \mu \text{m} \) thick AlN film and a 300 nm thick gold film were deposited on the top side and etched to form a sandwiched piezoelectrode stack (Figure 1b). The resonant beam was formed by back side wet etching and then released by a dry etching process (Figure 1c). Figure 2 shows an optical micrograph of a fabricated resonator.

2.2. Device packaging

Two resonator packages were used to investigate the hydrodynamic loading effects in free space or close to a surface. For vibration in free space, the resonator chip was mounted on a printed circuit board, with a pre-drilled hole (c.f. Figure 3a and b), and the resonator is suspended several millimeters away from any surface, much bigger than the resonator dimensions. For vibration
close to a surface, a curved cover was clamped on the top surface of the resonator (c.f. Figure 3c, d), and the cavity depth \( h_0 \) of the cover varies from 20 to 300 \( \mu \text{m} \).

2.3. Measurement setup

The packaged resonator is then mounted on an electronic circuit (whose major functions are electrical crosstalk compensation and signal amplifier, for details one can refer to [18, 19]) and then placed in a custom-built vacuum chamber, wherein the pressure can be controlled from atmospheric pressure down to high vacuum (lower than \( 10^{-4} \) mbar). Meanwhile, five noble gases (He, Ne, Ar, Kr, and Xe) and \( \text{N}_2 \) are used to observe the resonator performance variation.
The noble gases are chosen in this work, since they are all monatomic gases with gradually increasing density and decreasing sound speed under standard conditions. Figure 4 shows (a) the camera picture (the gas bottles are behind the chamber, not shown in the picture) and (b) the schematic diagram of the measurement setup used to characterize the resonator behavior.

2.4. Electric readout

The resonance frequencies and $Q$ factors of the packaged resonators were measured and characterized under controlled pressures. For vibrations in a high vacuum ($10^{-4}$ mbar), a high $Q$ value can be achieved and the fluidic damping is negligible. Increasing the ambient pressure results in a slight shift in $f$, but a dramatic reduction in the $Q$ factor, as shown by example resonant curves in Figure 5.

3. Hydrodynamic loading on vibrating microresonators

In this section, the research interest is focused on beam-shaped resonators operating in gas media. First, the full set of Navier-Stokes (N-S) equation is semi-analytically solved, and the solution can be interpreted by a “three wave theory” with coupled viscous, thermal, and acoustic waves. Second, for slender structures at moderate reduced pressures, viscous drag is typically the dominant loss mechanism. The influence of the fluid’s viscosity, density, and compressibility on the energy loss of the vibrating beam is discussed. Third, in many practical
applications, resonators are vibrating near a surface, and the influence of the vicinity on such a surface is experimentally and analytically evaluated.

3.1. Full N-S model and numerical simulation

For a continuous fluid, the most extensive type of theoretical model is based on the full set of N-S equations, which takes into account of fluid compressibility, thermal conductivity, and viscosity. The variables are density, pressure, temperature, and velocity that all vary around the resonator.

3.1.1. Theory

The basic equations governing the fluid motion induced by vibration are the compressible N-S equation, the equation of continuity, the equation of state for an ideal gas, and the energy equation [20]. The equations can be written as:
\[
\frac{\partial \mathbf{u}}{\partial t} + (\mathbf{u} \cdot \nabla) \mathbf{u} = -\frac{1}{\rho} \nabla p + \frac{4 \eta}{3 \rho} \nabla (\nabla \cdot \mathbf{u}) - \frac{\eta}{\rho} \nabla \times (\nabla \times \mathbf{u}),
\]
(1)

\[\rho (\nabla \cdot \mathbf{u}) + \frac{\partial p}{\partial t} = 0,\]
(2)

\[p = (C_p - C_v) \rho T,\]
(3)

\[\rho C_p \frac{\partial T}{\partial t} = \kappa \Delta T + \frac{\partial p}{\partial t},\]
(4)

where \(\mathbf{u}, C_v,\) and \(t\) denote, respectively, the velocity vector, heat capacity at constant volume, and time. The operators \(\nabla\) and \(\Delta\) are the gradient and Laplace operator, respectively.

A solution of the full model called Boundary Element Method (BEM) [21, 22] is discussed here. The velocity is written as the sum of a viscous velocity \(\mathbf{u}_v\), due to viscous effects, and a laminar velocity \(\mathbf{u}_l\):

\[\mathbf{u} = \mathbf{u}_v + \mathbf{u}_l,\]
(5)

which satisfy the conditions that the divergence of the viscous velocity is zero: \(\nabla \cdot \mathbf{u}_v = 0\), and the rotation of the laminar velocity is zero: \(\nabla \times \mathbf{u}_l = 0\).

The pressure is also split up into two components:

\[p = p_a + p_h,\]
(6)

where \(p_a\) is the acoustic pressure and \(p_h\) is the thermal pressure. Splitting the acoustic variables...
facilitates rewriting the governing equations into scalar wave equations for the acoustic and thermal pressures and a vector wave equation for the viscous velocity:

\[
\Delta + k_a^2 \frac{\partial}{\partial t} p_a = 0, 
\]
\[
\Delta + k_h^2 \frac{\partial}{\partial t} p_h = 0, 
\]
\[
\Delta + k_v^2 \frac{\partial}{\partial t} u_v = 0. 
\]

The temperature fluctuation \(\Delta T\) is the sum of acoustic and thermal temperature variations related to the acoustic and thermal pressures by:

\[
\Delta T = \alpha_a p_a + \alpha_h p_h, 
\]

and the laminar velocity \(u_l\) is written as:

\[
u_l = \phi_a \nabla p_a + \phi_h \nabla p_h. 
\]

The exact expressions for \(k_a, k_h, k_v, \alpha_a, \alpha_h, \phi_a\), and \(\phi_h\) can be found in the literatures [21, 22].

3.1.2. **Physical interpretation**

The solution of the full N-S model can be interpreted as follows: the resonator vibration results in acoustic wave propagation in the ambient fluid. The acoustic domain can be divided into a boundary layer and the bulk region, as illustrated in **Figure 6**. In microscaled geometries, the boundary layer occupies a substantial part of the acoustic domain, the acoustic model needs to account for the viscothermal effects to accurately describe the wave propagation.

Mechel [23] describes the viscothermal acoustic equations as the interaction of viscous, thermal, and acoustic waves. The viscous \(k_v\), thermal \(k_h\), and acoustic \(k_a\) wave numbers are derived as: \(k_v^2 = -i\omega \rho_p / \eta\), \(k_h^2 = -i\omega \rho C_p / \kappa\), and \(k_a^2 = \omega / c_0\). Viscous and thermal waves are heavily damped, as their wavelengths \(\lambda_v\) and \(\lambda_h\) have comparable length scales with the boundary layer.

**Figure 6.** Two regions in the acoustic domain: the bulk and the boundary layer, and three waves due to vibration.
thickness; while the acoustic wave is slightly damped and propagates mainly in the bulk regime. Figure 7 compares these characteristic length scales for vibration in air at frequencies from 1 kHz to 1 MHz.

For microresonators vibrating at low frequencies, the characteristic length of the resonator (e.g., width of the resonant beam) is much smaller than the acoustic wavelength propagating in the fluid. The acoustic wave develops so weakly that the bulk region can be ignored and the fluid is assumed as incompressible, and the vibration energy is mainly dissipated due to the viscothermal effects. Consequently, the fluid motion can be modeled accurately by incompressible N-S equations. However, as frequency increases, the acoustic wavelength reduces to smaller than the characteristic length of the resonator. The bulk regime can become significant and the acoustic wave starts to radiate vibration energy. Therefore, compressibility can become important for operation at higher frequencies.

3.1.3. Comparison between experiments and simulations

Resonators with different geometry and dimensions have been fabricated to verify the predictions of the full N-S model. One of the AlN-based resonators is shown in Figure 8, the insert shows the resonator chip mounted on a printed circuit board. The resonator has been tested from high vacuum to normal atmosphere.

The full model equations are solved and simulated with a self-developed FEM solver using MATLAB. Figure 9 shows the simulated pressure, density, temperature, and velocity amplitude distributions of the air gap in the \(xz\) plane at 0.01 and 1000 mbar. The amplitude profiles in Figure 9 indicate that, compared to vibration in the higher pressure, the pressure and density perturbation are more constant, and the temperature is more homogeneous across the air gap in the lower pressure.

The measured and simulated air damping coefficients under different pressures are shown in Figure 10. This figure indicates that simplified models, such as viscous model or squeeze model, are not suitable in this case, since they are accurate only for resonators with slim beams.
or narrow air gaps. In the free molecular region, the free molecular model is reasonable. The full N-S model yields good agreement in the whole pressure range.

3.2. Hydrodynamics of microresonators vibrating in unbounded fluids

3.2.1. Measurement results at atmospheric pressure

The AlN-based microresonators were tested in the chamber filled with different gases under atmospheric pressure, as shown in Figure 11. The resonance curve variations indicate that the resonance frequency $f_r$ decreases as the density of the gas increases, shifting from 7 kHz for He ($\rho = 0.18 \text{ kg/m}^3$) to 6.91 kHz for Xe ($\rho = 5.90 \text{ kg/m}^3$).
To excite the cantilever in higher resonant modes, the frequency of the driving voltage was scanned from 5 to 250 kHz. Figure 12 shows the resonance frequency response of the cantilever in N\textsubscript{2} at atmospheric pressure. Finite element analysis software COMSOL was used to assign the resonant modes to the observed peaks. The resonant mode shapes inserted in the figure are obtained by this software and depict the displacement of the cantilever for each mode.

**Figure 10.** Air damping coefficient of the resonator as a function of ambient pressure [24].

**Figure 11.** Resonant measurements of the cantilever with different gases at atmospheric pressure in its first flexural mode [25].
To evaluate the fluidic hydrodynamic loading effects, the cantilever vibrating in different resonant modes has been characterized in different gases at atmospheric pressure. Only the first two modes for Kr and Xe could be detected, since the signal of higher modes was too weak. The remaining gases are successfully characterized up to the fourth flexural mode. Pure fluidic hydrodynamic loading is evaluated by subtracting the intrinsic damping, which can be measured in a high vacuum.

The quality factor induced by gas damping $Q_{\text{gas}}$ in atmospheric pressure is characterized and illustrated in Figure 13. Resonator immersed in He shows the highest $Q$ factors for all modes. The two lightest gases, He and Ne, exhibit a continuous increase in $Q_{\text{gas}}$ with the mode number, whereas for Ar and N$_2$, $Q_{\text{gas}}$ decreases beyond the third mode. Taking N$_2$ as an example, the measured values of $Q_{\text{gas}}$ increase from 543 to 1890 for the first to third mode.

![Figure 12](image12.png)

**Figure 12.** Amplitude spectrum and mode shapes of the cantilever at normal atmospheric N$_2$ [25].

![Figure 13](image13.png)

**Figure 13.** $Q$ factors due to gas damping of the different flexural modes at atmospheric pressure [25].
modes. However, this trend is broken when $Q_{\text{gas}}$ reduces to 1645 for the fourth flexural mode, indicating that $Q_{\text{gas}}$ will not increase in an unlimited way with increasing mode/frequency.

The corresponding resonance frequency shift $\Delta f$, defined as $f_{r,\text{vac}}/C_0 f_r$, where $f_{r,\text{vac}}$ corresponds to the resonance frequency $f_r$ in vacuum, has been characterized. Figure 14 shows $\Delta f$ as a function of density $\rho$ for different gases. The results in this figure indicate a dependence on both $f_r$ and $\rho$.

3.2.2. Measured results at reduced pressures

The resonators were further tested at reduced pressures to investigate the influence of ambient pressure. Figure 15 shows the measured $Q$ factor curve of one resonator vibrating at the first flexural mode as a function of $N_2$ pressure. When the pressure is sufficiently low (<10^{-3} mbar in this figure), the damping is independent of the fluid and relates only with intrinsic losses in the resonator structure. Consequently, this pressure regime is called the intrinsic regime. Gas damping starts to become visible at higher pressure levels. Three regions can be identified by using the Knudsen number $Kn$ (defined as the ratio between the mean free path of the fluid and the width of the resonator):

- The molecular regime ($Kn > 10$): damping is caused by independent collisions of non-interacting fluid molecules with the vibrating surface of the resonator and/or surrounding walls.
- The transition regime ($0.01 < Kn < 10$): the fluid is neither noninteracting nor continuous.
- The continuous regime ($Kn < 0.01$): the fluid acts as continuum and most previous papers (e.g., [26, 27]) found that the viscous drag is typically the dominant energy loss mechanism based on the incompressible gas assumption.

![Figure 14. Resonance frequency shifts $\Delta f$ of the different flexural modes at atmospheric pressure [25].](image)
3.2.3. Results analysis

It is found that the fluidic loading has a strong effect on the resonant behavior of the resonator, especially at higher pressures (e.g., near atmospheric pressure). The following analysis focuses on fluidic damping at atmospheric pressure, which is commonly present in many practical applications.

Viscous drag is typically the dominant loss mechanism, for most microdevices vibrating at relatively low frequency. For a microcantilever with dimensions of length $l$, width $w$, and thickness $h$, undergoing flexural vibrations in a continuous incompressible fluid, the corresponding $Q$ factor due to viscous damping is given by [25, 28, 29]:

$$Q_{\text{vis}} \approx \frac{rb}{\eta} \left( \frac{fr}{\sqrt{\pi}} \right),$$

(12)

where $r_b$ is the cantilever beam density. It can be seen that the $Q$ factor scales inversely proportional with $\sqrt{\eta}$ and proportional with $\sqrt{fr}$, which means that a higher resonance frequency (or higher resonant mode) results in a higher $Q$ factor. The measured and calculated $Q$ factors $Q_{\text{vis}}$ of the different flexural modes are plotted in Figure 16 as a function of the combination of the resonance frequency $f_r$, the density $\rho$, and the viscosity $\eta$ of the surrounding gases. However, as noted before, a decrease of the quality factor is observed for the third and fourth modes of Ar and N$_2$.

One possible reason is the additional acoustic damping due to the compression of the fluid. Incompressible flow is expected for low frequency vibrations, since the wavelength of sound in the fluid is much longer than the dominant length scale of the vibrating beam. As the resonant mode increases, the acoustic wavelength reduces and the incompressible gas assumption is no...
longer valid [25, 29, 30]. Thus, at high frequencies, acoustic energy loss becomes important in addition to viscous loss.

3.3. Hydrodynamics of microresonators vibrating close to a surface

3.3.1. Measured results

We have measured bridge resonator different gap depths to understand how fluidic hydrodynamic load is modified when the resonator is vibrating near a surface. The case of vibration at free space was also measured for comparison. We begin by presenting results of the resonance responses of the resonator immersed in atmospheric N\(_2\) at room temperature, as shown in Figure 17.

It is obvious that the air gap has a strong effect on the resonance behavior. A general trend is the resonance peak getting broaden and shifting to lower peak frequency as the gap depth decreases. There results fit with the expectation that the fluidic damping increases significantly when approaching toward a surface. We have also observed that the resonance frequency shift is relatively insensitive to air gap when the separation \(h_0\) is bigger than 150 \(\mu\)m, which corresponds to a gap to the resonator width ratio of more than 0.5. However, for \(h_0 = 150\ \mu\)m, the Q factor is approximately 20% less than vibration without gap, and for \(h_0 = 250\ \mu\)m, the Q factor differs by only less than 2%.

To quantify the pressure effect on the dissipation in the fluid as the resonator is vibrating near a surface, it was further measured under reduced pressures. Figure 18 shows the quality factors for different gap heights and pressures in N\(_2\) atmosphere.

3.3.2. Review of analytical models

In many practical applications, restrictive squeeze-film assumption (very narrow air gap) does not always hold; thus, traditional squeeze-film models are not suitable in those cases. Two
recently improved models, namely (a) extended squeeze-film model [32, 33] and (b) unsteady N-S model [34–36], are considered for describing the behavior of the resonators with moderate gap depths.

Figure 17. Resonant curves of a bridge resonator in fundamental mode at atmospheric N₂. The curves for gap depths of 250 and 300 μm and ∞ are overlapped. The dashed lines in the inserted figure represent the limit for the resonator at free space [31].

Figure 18. Variation of Q factors with ambient pressure for N₂ with different gap heights [31].
3.3.2.1. Extended squeeze-film model

Osborne Reynolds first formulated the theory for a squeezed film between two surfaces in relative motion to each other more than a century ago [37]. Generally, the compressibility should be considered and its importance increases as vibration frequency. An important measure for the squeezed-film effect is the squeeze number:

$$
\sigma = \frac{12 \eta w^2 \omega}{p h_0^2},
$$

(13)

where \( \eta \) is the fluid viscosity, \( \omega \) is the angular frequency of the resonator, \( p \) is the ambient pressure, \( w \) is the width of the resonator, and \( h_0 \) is the gap depth. The number \( \sigma \) specifies the ratio between the spring force due to the gas compressibility and the force due to the viscous flow. When \( \sigma \) is much smaller than 1, the gas in the film has enough time to "leak" out; thus, the gas is referred to as incompressible. For the resonator geometry in this study, the resonator width \( w \) and the gap depth \( h_0 \) are of the same order, e.g., \( h_0/w > 0.05 \). For air at atmospheric pressures, the vibrating frequency should be higher than 150 kHz to ensure \( \sigma \) is bigger than 1.

When \( \sigma \) is very small, the compressible effects can be ignored and the damping coefficient for a slender resonator can be written as:

$$
c = \frac{\eta lw^3}{h_0^3},
$$

(14)

and \( Q \) factor is then given by:

$$
Q = \frac{\rho_l l \omega}{\eta w^2 h_0^3},
$$

(15)

herein \( \rho_l \), \( l \) and, \( t \) are the density, length, and thickness of the resonator, respectively.

An effective plate width \( w_{eff} = w + \Delta w \) is introduced, to include border effects into the much simplified squeeze-film model. The effective width is such that the damping force for the enlarged plate with trivial boundary conditions has the same values as that of a real device size with the border effects. This concept is illustrated in Figure 19.

One method to predict the elongation caused by the border effect was proposed by Veijola et al. [32, 33], based on a series of 2D and 3D FEM simulations. A simple conclusion has been obtained for a slender beam:

![Figure 19](image.png)

Figure 19. Schematic diagram of extended squeeze-film model.
The fluidic damping coefficient due to air gap is:

$$c = \frac{\eta (w + 1.3h_0)^3}{h_0^3}.$$  \hspace{1cm} (17)

The quality factor consequently is:

$$Q = \frac{\rho _0 \omega w}{\eta (w + 1.3h_0)^3 h_0^3}.$$ \hspace{1cm} (18)

To account the non-continuum fluid behavior at very low pressures or for a narrow gap, an effective viscosity $\eta_{\text{eff}}$ is used instead of the gas dynamic viscosity $\eta$. Burgdoufer [38] obtained a simple form for the effective viscosity coefficient:

$$\eta_{\text{eff}} = \frac{\eta}{1 + 6K_n}.$$ \hspace{1cm} (19)

3.3.2.2. Unsteady N-S model

Another method to deal with moderate gaps can be based on the unsteady incompressible N-S equation and the continuity equation [20]. For a beam undergoing normal oscillations in a viscous fluid, the general form of the hydrodynamic force in the vibration direction is given as [39]:

$$F_d = \frac{\pi}{4} \rho_0 \omega w^2 \Gamma(Re) W(x/\omega),$$ \hspace{1cm} (20)

where $\rho$ is the fluid density, $W$ is the Fourier transformation of the resonator beam deformation, $\Gamma$, the so-called “hydrodynamic function”, is a complex term: the real part $\Gamma_{\text{real}}$ represents the inertial forces of the fluid or added mass components, whereas the imaginary part $\Gamma_{\text{imag}}$ is proportional to the viscous forces of the fluid or damping components.

The general form of the semi-analytical formula for the hydrodynamic function is $\Gamma(Re, H) = 10^{\Gamma_L}$, where

$$\Gamma_L(Re, H_L) = a_1 + a_2 Re_L + a_3 Re_L^2 + a_4 Re_L^3 + a_5 Re_L^4 + a_6 Re_L H_L + a_7 H_L^2 + a_8 H_L^3 + a_9 H_L^4 + a_{10} H_L^5 + a_{11} Re_L H_L^2 + a_{12} Re_L H_L^3 + a_{13} Re_L H_L^4 + a_{14} Re_L H_L^5 + a_{15} (Re_L H_L)^2 + a_{16} (Re_L H_L)^3,$$ \hspace{1cm} (21)

$H_L = \log_{10}(H)$, and $Re_L = \log_{10}(Re)$. The coefficients $a_k$, $k = 1, 2, \ldots, 16$, have complex values. They are tabulated in Tung et al.’s paper [36]. The fit is valid in the range of $10^{-2} < Re < 10^4$ and $10^{-1} < H < 10$. The $Q$ factor due to the fluid damping is defined by
\[ Q = \frac{4\rho_w \Gamma_{\text{imag}}}{\pi \mu \omega} \] (22)

The calculations are technically valid only when the continuum hypothesis holds. This is because the theory is based upon a subset of the N-S equations, which are based on a continuum assumption. The useful range of this semi-analytical expression can be extended beyond the continuum regime and into the slip and transition regimes by using an effective viscosity concept.

3.3.3. Results analysis

The predictions from squeeze film (Eq. (13)), extended squeeze film (Eq. (18)), unsteady N-S (Eq. (22)), and viscous (Eq. (12)) models are compared with the experimental data. Figure 20 shows the results for the first flexural mode of the bridge resonator oscillating in atmospheric \( N_2 \) with different gap depths. The intrinsic damping of the resonator can be obtained by operating in a high vacuum, and this damping was subsequently removed mathematically, leaving only the fluidic damping to be analyzed.

The traditional squeeze-film damping model overestimates the Q factor and the divergence increases rapidly as the gap depth increases. While the extended squeeze-film model predicts well the squeeze-film damping up to gap depth of 50 \( \mu m \). This model accurately predicts the fluidic damping well even into the free molecular regime, indicating the “effective viscosity” concept is reasonable to account the rarefaction effect of the gas in a narrow gap. The unsteady N-S model predictions are in better agreement with measurements as compared to other models. The viscous model fits well with the measurements in the viscous regime, but when the pressure decreases into the transition regime, this model loses its validity.

![Figure 20](image.png)

*Figure 20.* Q factors due to fluidic damping of a resonator. The squares represent the measurements, and the dashed lines represent the analytical/semianalytical calculations, while the solid line shows the viscous model prediction [31].
4. Conclusion and discussion

In this work, AlN-based piezoelectric microresonators have been fabricated and measured to study the fluidic hydrodynamic loading mechanisms. Experimental, computational, and analytical tools have been developed, to analyze the dynamics of the resonators in different gases from atmospheric pressure to high vacuum.

For resonators vibrating in a continuous fluid, the extensive type of theoretical model is based on the full set of N-S equations. The equations were semi-analytically solved using the BEM method. The solution can be interpreted as coupling of viscous, thermal, and acoustic waves. However, this method does have some disadvantages, such as being computationally costly, relying on sophisticated numerical techniques, and being non-intuitive with respect to understand the results physically.

The resonators vibrating in free space fluids have been investigated, by measuring microcantilevers in different gases and explaining the results using simplified models based on the incompressible N-S equation. The analytical models agree reasonably with measurements. Besides, it is found that the compressibility of gases leads to additional acoustic damping when vibrating in higher mode/frequency.

For vibration close to a surface, experiments were performed using a bridge resonator with a big range of gap depths. The traditional squeeze-film model could predict the squeeze-film damping when the ratio of the resonator width to gap height \( \frac{w}{h_0} \) was bigger than 10, and the gas rarefaction effect in the gap can be accounted by using an “effective viscosity” concept. The extended squeeze-film model was valid for \( \frac{w}{h_0} \geq 4 \). The unsteady N-S model could be used when the gap height was even bigger.

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